

# ISO 17168-1:2018 (E)

## Fine ceramics (advanced ceramics, advanced technical ceramics) — Test method for air-purification performance of semiconducting photocatalytic materials under indoor lighting environment — Part 1: Removal of nitric oxide

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### Contents

|         |   |
|---------|---|
|         | Foreword  |
|         | Introduction  |
| 1       | Scope   |
| 2       | Normative references                                    |
| 3       | Terms and definitions                                   |
| 4       | Symbols   |
| 5       | Principle   |
| 6       | Apparatus   |
| 6.1     | Test equipment  |
| 6.2     | Test gas supply   |
| 6.3     | Photoreactor  |
| 6.4     | Light source  |
| 6.5     | UV sharp cut-off filter                                 |
| 6.6     | Analyser of pollutants                                  |
| 7       | Test piece  |
| 8       | Procedure   |
| 8.1     | General aspects   |
| 8.2     | Pretreatment of test piece                              |
| 8.3     | Pollutant removal test                                  |
| 8.4     | Elution test  |
| 9       | Calculation   |
| 9.1     | Calculation method                                      |
| 9.2     | Amount of NO <sub>x</sub> adsorption by the test piece  |
| 9.3     | Amount of NO removed by the test piece                  |
| 9.4     | Amount of NO <sub>2</sub> formed by the test piece      |
| 9.5     | Amount of NO <sub>x</sub> desorbed from the test piece  |
| 9.6     | Net amount of NO <sub>x</sub> removed by the test piece |
| 9.7     | Nitrogen eluted from the test piece                     |
| 9.8     | Recovery of washing with water                          |
| 10      | Test method for test pieces with lower performance      |
| 11      | Test report   |
| Annex A | (informative) Results of an interlaboratory test        |